

In re: Freese et al.
Application No.: 10/661,917
Filed: September 11, 2003
Page 2 of 3

In the Title:

Please amend the title in all occurrences as follows:

~~SYSTEMS AND METHODS FOR MASTERING MICROSTRUCTURES THROUGH
A SUBSTRATE USING NEGATIVE PHOTORESIST AND MICROSTRUCTURE
MASTERS SO PRODUCED.~~